



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Naoto Kusumoto et al.

Art Unit: 2828

Serial No.: 10/602,762

Examiner: Unknown

Filed

: June 25, 2003

Title

: LASER ANNEALING METHOD

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

## **INFORMATION DISCLOSURE STATEMENT**

Applicants submit the references listed on the attached form PTO-1449.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

Desig. ID	Source
AL	Japan 02-224346: English Abstract - File 345: Inpadoc/Fam. & Legal
	Stat., Accession No. 9471918 (2003)
AM	Japan 06-318701: English Abstract - File 345: Inpadoc/Fam. & Legal
	Stat., Accession No. 12104562 (2003) and family of US 5,569,610
	(Desig. ID "AA"), US 5,614,733 (Desig. ID "AB") and US 5,783,468
	(Desig. ID "AC")
AN	Japan 08-051074: English Abstract - File 352: Derwent WPI,
	Accession No. 010672119 (2003)

This statement is being filed before the receipt of a first Office action on the merits.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: December 1, 2003

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Attorney's Docket No. 07977-004002

Application No. 10/602,762

Form PTO 1949

U.S. Department of Commerce attent and Trademark Office Information Disclosure Statement by Applicant (Use several sheets if necessary)

Applicant Naoto Kusumoto et al.

Filing Date June 25, 2003

Group Art Unit 2828

Substitute Disclosure Form (PTO-1449)

(37 CFR §1.98(b))

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,569,610	10/29/1996	Zhang et al.			03/08/1994
	AB	5,614,733	03/25/1997	Zhang et al.			12/12/1994
	AC	5,783,468	07/21/1998	Zhang et al.			04/10/1996
	AD						
	AE						
	AF						
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	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner	Desig.	Document	Publication	Country or	Q1	Cubalasa		lation
Initial	מו	Number	Date	Patent Office	Class	Subclass	Yes	No
	AL	02-224346	09/06/1990	JAPAN			ABS	
	AM	06-318701	11/15/1994	JAPAN			ABS	
	AN	08-051074	02/20/1996	JAPAN			ABS	
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)			
Examiner Initial	Desig. ID	Document	
	AQ		
	AR		
	AS		
	AT		

Examiner Signature	Date Considered
	in the second description of this form with
EXAMINER: Initials citation considered. Draw line through citation if n	of in conformance and not considered. Include copy of this form with
next communication to applicant.	O. L. W. L. Displaying Form (DTO 1440)